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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Re Application of

Mitsuhiro NISHIDA et al

U.S. Patent Application No. 10/804,073

Filed: March 19, 2004

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: Confirmation No. 7052
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: Group Art Unit: 1775
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: Examiner:

For: METHOD OF PRODUCING ANTI-REFLECTION FILM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith are Information Disclosure Statement, Japanese Action and three references.


It is certified that the Japanese Action and the references were issued on September 11, 2007 and each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

In the Action, claim 1 was rejected by the references 1, 2 and 3, claim 2 was rejected by the reference 1, claims 3 and 4 were rejected by the reference 1, Claim 5 was rejected by the reference 1, claims 6 and 7 were rejected by reference 1 and claim 8 was rejected by reference 1.

Reference 1, Japanese publication H09-73001;
Reference 2, Japanese publication H10-186104;
Reference 3, Japanese publication H09-165231.

Respectfully submitted,

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